IN THE CLAIMS

Please amend claims 1, 9, 10, 12, 13, 15, 16 and 25 as follows:

1. (Currently Amended) A field emission display, comprising: 1 a first substrate; 2 an electron emission assembly arranged on said first substrate; 3 a second substrate arranged a predetermined distance from said first substrate, said first and second substrates forming a vacuum space; 5 an illumination assembly arranged on said second substrate, said illumination 6 assembly being illuminated by electrons emitted from said electron emission assembly; 7 and a mesh grid arranged above said electron emission assembly, the mesh grid including an effective screen portion having a plurality of beam passage holes arranged in 10 a predetermined pattern and having an inactive portion absent any beam passage holes. 11 The field emission display of claim 1, wherein said mesh grid 2. (Original) 1 comprises a metal. 2 The field emission display of claim 1, wherein said mesh grid 3. (Original) 1

comprises one of stainless steel, invar, and an iron-nickel alloy.

2

- 4. (Original) The field emission display of claim 3, wherein the iron-nickel alloy comprises 2.0 to 10.0 wt% of Cr.
- 5. (Original) The field emission display of claim 3, wherein the iron-nickel alloy comprises 40.0 to 44.0 wt% of Ni.
- 6. (Original) The field emission display of claim 3, wherein the iron-nickel alloy comprises 0.2 to 0.4 wt% of Mn, 0.7 wt% or less of C, and 0.3 wt% or less of Si.
 - 7. (Original) The field emission display device of claim 1, wherein the thermal expansion coefficient of said mesh grid is in the range of 9.0 x 10⁻⁶/°C to 10.0 x 10⁻⁶/°C.

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- 8. (Original) The field emission display device of claim 1, wherein electron emission assembly comprises a cathode and a gate and an electron emission source.
- 9. (Currently Amended) The field emission display device of claim [[9]] 8, wherein said gate is arranged on an upper side of said cathode.
- 10. (Currently Amended) The field emission display device of claim [[9]] 8, wherein the gate is arranged on a lower side of said cathode.

| _ | 11. (Outsing) The field emission display device of claim 1 wherein an |
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| 1 | 11: (Original) The field emission display device of claim 1, wherein an |
| 2 | intermediate material is arranged between said electron emission assembly and said mesh |
| 3 | grid. |
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| 1 | 12. (Currently Amended) The field emission display device of claim [[1]] 11, |
| 2 | wherein said intermediate material comprises an insulating material. |
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| l | 13. (Currently Amended) The field emission display device of claim [[12]] 11, |
| 2 | wherein said intermediate material comprises a resistive material. |
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| 1 | 14. (Original) The field emission display device of claim 1, further comprising a |
| 2 | focusing electrode arranged on said mesh grid. |
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| 1 | 15. (Currently Amended) A field emission display device, comprising: |
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| 2 | a first substrate; |
| 3 | an electron emission assembly arranged on said first substrate; |
| 4 | a second substrate arranged a predetermined distance from said first substrate, said |
| 5 | first and second substrates forming a vaccum assembly; |
| 6 | an illumination assembly arranged on said second substrate, said illumination |
| 7 | assembly being illuminated by electrons emitted from said electron emission assembly; |
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and

| 9 | a mesh grid arranged above said electron emission assembly, the mesh grid |
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| 0 | including an effective screen portion having a plurality of beam passage holes arranged in |
| 1 | a predetermined pattern and having an inactive portion absent any beam passage holes; |
| 2 | wherein said mesh grid is bonded to said electron emission assembly by a frit. |
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| 1 | 16. (Currently Amended) A method of manufacturing a field emission display, |
| 2 | the method comprising: |
| 3 | providing a first substrate; |
| 4 | arranging an electron emission assembly on said first substrate; |
| 5 | arranging a second substrate a predetermined distance from said first substrate to |
| 6 | form a vacuum space with said first and second substrates; |
| 7 | arranging an illumination assembly on said second substrate, and illuminating said |
| 8 | illumination assembly with electrons emitted from said electron emission assembly; and |
| 9 | arranging a mesh grid above said electron emission assembly, the mesh grid |
| 0 | including an effective screen portion having a plurality of beam passage holes arranged in |
| 1 | a predetermined pattern and having an inactive portion absent any beam passage holes. |
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| 1 | 17. (Original) The method of claim 16, further comprising forming said mesh |
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18. (Original) The method of claim 16, further comprising forming said mesh

grid of a metal.

2

grid of one of stainless steel, invar, and an iron-nickel alloy. 2 19. (Original) The method of claim 16, further comprising forming a cathode and 1 a gate and an electron emission source in said electron emission assembly. 2 20. (Original) The method of claim 19, further comprising forming said gate on 1 one of an upper an lower side of said cathode. 2 The method of claim 16, further comprising forming an 21. (Original) 1 intermediate material between said electron emission assembly and said mesh grid. 2 22. (Original) The method of claim 21, further comprising forming said 1 intermediate material of an insulating material. 2 The method of claim 21, further comprising forming said 23. (Original) 1 intermediate material of a resistive material. 2 24. (Original) The method of claim 16, further comprising forming a focusing 1 electrode on said mesh grid. 2

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25. (Currently Amended) A method of manufacturing a field emission display

| 2 | device, the method comprising: |
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| 3 | providing a first substrate; |
| 4 | arranging an electron emission assembly on said first substrate; |
| 5 | arranging a second substrate a predetermined distance from said first substrate to |
| 6 | form a vaccum assembly with said first and second substrates; |
| 7 | arranging an illumination assembly on said second substrate and illuminating said |
| 8 | illumination assembly with electrons emitted from said electron emission assembly; |
| 9 | arranging a mesh grid above said electron emission assembly the mesh grid |
| 10 | including an effective screen portion having a plurality of beam passage holes arranged in |
| 11 | a predetermined pattern and having an inactive portion absent any beam passage holes; |
| 12 | and |
| 13 | bonding said mesh grid to said electron emission assembly with a frit. |